

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/549,440 Confirmation No. 5587  
Applicant : Takeo Okabe  
371 Filed : September 16, 2005  
Art Unit : 1793  
Examiner : Sikyin Ip  
Customer No. : 00270  
Title : COPPER ALLOY SPUTTERING TARGET, PROCESS FOR PRODUCING THE SAME AND SEMICONDUCTOR ELEMENT WIRING

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This is an Amendment submitted in timely response to a non-final Office Action dated July 8, 2009. Kindly amend the application as set forth below.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.